

PATENT
Atty. Dkt. No. AMAT/6060/CMP/ECF/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Olgado, et al.

Serial No.: 10/043,561

Confirmation No.: 7947

Filed: January 8, 2002

For: System for Planarizing
Metal Conductive Layers

Group Art Unit: 1765

Examiner: Kin Chan Chen

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Commissioner for Patents
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TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number (703) 872-9306 to the attention of the named Examiner, on the date below.

2/20/04

Date

Kin Chan Chen

Signature

Dear Sir:

SECOND RESPONSE TO FINAL OFFICE ACTION DATED OCTOBER 20, 2003

In response to the Final Office Action dated October 20, 2003, having a shortened statutory period for response extended one month to expire on February 20, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6060/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are listed beginning on page 2 of this paper. Remarks begin on page 5 of this paper.

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